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ACT Receipt #5

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Unknown

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING

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**SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

Sir:

We enclose a copy of the Corrected Official Filing Receipt, as well as the first Request for Corrected Official Filing Receipt, for the above-identified application and request the following correction:

**IN THE TITLE:** delete "fro" and insert therefor --for--.

Verification for the requested correction is indicated on the first Request for Corrected Official Filing Receipt filed April 19, 2001, as well as the original Declaration and Power of Attorney filed February 20, 2001.

Respectfully submitted,

Christopher R. Lipp  
Registration No. 41,157

SUGHRUE MION, PLLC  
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Date: December 5, 2001

Attorney Docket No.: Q63075



## UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS  
UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/763,194	02/20/2001	1725	1020	Q63075	8	13	5

Sughrue Mion Zinn  
Macpeak & Seas  
2100 Pennsylvania Avenue NW  
Washington, DC 20037



CONFIRMATION NO. 3832

CORRECTED FILING RECEIPT



\*OC000000007052980\*

Date Mailed: 11/09/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Kazunobu Fujikawa, Tokyo, JAPAN;  
Akihiro Goto, Tokyo, JAPAN;

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## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP99/02379 05/07/1999

## Foreign Applications

If Required, Foreign Filing License Granted 03/21/2001

Projected Publication Date: Not Applicable, filed prior to November 29,2000

Non-Publication Request: No

Early Publication Request: No

## Title

Method and apparatus for surface discharge processing, and an electrode[fr]surface  
discharge processing

Preliminary Class

219

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Title 35, United States Code, Section 184  
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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**FILING RECEIPT**  
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In re application of

KAZUNOBU FUJIKAWA, et al.

Appln. No. 09/763,194

Group Art Unit: 1725

Confirmation No.: Not yet assigned

Examiner: Not yet assigned

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN  
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

PAPER(S) FILED ENTITLED:

1. Request For Corrected Official Filing Receipt, with copy of marked-up Official Filing Receipt
2. copy of Declaration and Power of Attorney

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ATTORNEY/SEC: RCT:te

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REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Commissioner for Patents  
Office of Initial Patent Examination  
Customer Service Center  
Washington, D.C. 20231

FILED  
APR 19 2001

Sir:


We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction(s):

**TITLE:** delete "METHOD AND APPARATUS FOR SURFACE TREATMENT BY ELECTRODISCHARGING, AND DISCHARGE ELECTRODE" and insert --METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING--

Verification for the requested correction(s) is indicated on the original Declaration and Power of Attorney filed February 20, 2001.

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Date: April 19, 2001